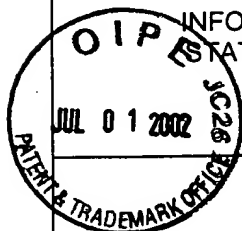


FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEAttorney Docket No.:  
GR 98 P 2516 PApplic. No.  
09/801,962

Applicant

Stefan Jung

Filing Date  
March 8, 2001Group Art Unit  
3623INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT  
(37 CFR 1.98(b))

## U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						

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## FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
	J						
	K						
	L						
	M						
	N						

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

Stefan Jung et al.: "A Low Power and High-Performance CMOS Fingerprint Sensing and Encoding Architecture", <i>ESSCIRC '98</i> , pp. 324-327	O /
	P
EXAMINER	DATE CONSIDERED
Amir ALAVI	2-20-2004

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449 (SUBSTITUTE)

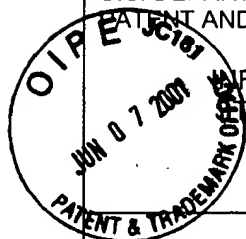
Attorney Docket No.:  
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09/801,962U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

Applicant

Stefan Jung

INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT  
(37 CFR 1.98(b))Filing Date  
March 8, 2001

Group Art Unit



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A. A.	A	4,162,481	07/24/79	DuVall	382	272	12-22-76
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## FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
A. A.	J ✓	0 786 745 A2	07/30/97	Europe	G07C	9/00	X
↓	K ✓	WO 98/52146	11/19/98	WIPO	G06K	9/20	X
	L						
	M						
	N						

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

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EXAMINER

AMIR ALAUI

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